IN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT APPLICATION

In re Application of:

Tran et al.

Atty. Docket: TI-37297

Serial No.:

TBD

Art Unit: TBD

Filed:

Herewith

Examiner: TBD

For:

AN IMPROVED CHEMICAL MECHANICAL POLISHING

METHOD AND APPARATUS

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98

Sir:

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO-1449. Pursuant to the new rule, no copies of these issued patents are being submitted. Please charge any necessary fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668. Charge any additional fee required or credit any overpayment to the same.

Texas Instruments Incorporated P. O. Box 655474, M/S 3999 Dallas, Texas 75265 (972) 917-5355 Respectfully submitted,

Yingsheng Jung Attorney for Applicant(s)

Reg. No. 52,305

FORM PTO-1449 (REV. 7-80)						ATTY. DOCKET NO.			SERIAL NO.		
LIST OF DOCUMENTS CITED BY APPLICANT (Use several sheets if necessary)						TI-37297			TBD		
						APPLICANT: Tran et al.					
						FILING DATE			GROUP		
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			U.S. PATEI	NT DOCU	MENTS						
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS		FILING DATE (IF APPROPRIATE)		
	5,605	,760	02/25/97	Roberts		428	409		08/21/95		
	5,578	,362	11/26/96	Reinhardt et al.		428	147		07/12/94		
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		OTHER DOCL	JMENTS (Inc	cluding Author	, Title, Date,	Pertinent Page	s, Etc.)				
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